













Nekrasov Pavel V. Course Schedule

MONDAY

10:15 — 11:50	■ LEC	Microprocessor Systems  S20-401  V-306
11:55 — 13:30	▣ SEM	Microprocessor Systems  S20-401  V-306
	▣ LAB	Microprocessor Systems  S20-401  V-306

TUESDAY

10:15 — 11:50	■ LEC	Design Automation of electronic devices  S20-401  V-306
11:05 — 13:30	■ SEM	Scientific Research Work (2024-02-13 — 2024-04-16)  S19-401  dep.3
14:30 — 16:05	■ SEM	Practical Training (Research Work)  S20-401  dep.3